

Docket No.: OGOSH46USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/567,729 Confirmation No. 7682  
Applicant : Kazutoshi Kojima et al.  
371 Filed : February 1, 2006  
Art Unit : 2814  
Examiner : Sarah Kate Salerno  
Customer No. : 00270  
Title : SILICON CARBIDE EPITAXIAL WAFER, METHOD FOR PRODUCING SUCH WAFER, AND SEMICONDUCTOR DEVICE FORMED ON SUCH WAFER

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment in response to a non-final Office Action dated September 3, 2008.  
Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.